

35.C11969 REI.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of: ) Examiner: L. Alejandro  
NOBUMASA SUZUKI )  
Application No.: 09/657,971 ) Group Art Unit: 1763  
Filed: September 8, 2000, )  
For: MICROWAVE PLASMA )  
PROCESSING APPARATUS AND )  
METHOD THEREFOR ) August 28, 2001

*ASANE  
9/7/01  
MW*

TC 1700  
SEP - 6 2001  
RECEIVED

**BOX REISSUE**  
Commissioner for Patents  
Washington, D.C. 20231

AMENDMENT

Applicants petition to extend the time for response to the Office Action dated February 28, 2001, for three (3) months, from May 28, 2001, to August 28, 2001. A check in the amount of \$890.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, and credit any overpayment, to Deposit Account 06-1205.

09/05/2001 VTRUONG1 00000063 09657971

01 FC:103 216.00 0P  
02 FC:117 890.00 0P

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on

August 28, 2001

(Date of Deposit)

*BRENDAN MEE*

Name of Attorney for Applicant)

*Brendan Mee*

Signature

August 28, 2001

Date of Signature